

[ICMOVPE XXII Special Session]

# Compound Semiconductor Networking Reception

July 15 (Wed.)

ROOM 202(ICC JEJU, Jeju Island, Korea)

A networking session to share the latest technology and industry trends in compound semiconductor epitaxy, and to promote collaboration among domestic and international experts from academia, industry, and research institutions.

Time	Program	
15:00-16:00(60')	KANC Info Session (Individual Meeting)	
16:00-16:20(20')	Opening & Photo Time	
16:20-16:40(20')	Introduction of KANC Epi. platforms	Dr. Chuyoung Cho (KANC)
16:40-17:00(20')	MOCVD Based Next-Generation GaN Epiwafer Technologies for Power and RF Applications by WaveLord	Young-Hun Han (WaveLord)
17:00-17:20(20')	AlN-platform Technology - Present and Future	Dr. Jung-Hee Lee (L&D)
17:20-17:40(20')	8 inch GaN on Si Epiwafer and HEMT Device Manufacturing Technology and Application	Dr. Hyun-Jun Jo (A-PRO Semicon)
17:40-	Closing / Dinner	

\* Free Buffet Dinner

## Contact

M : donghwan.shin@kanc.re.kr

T : +82-31-546-6521

## To Apply

1. QR code scan

2. Visit : <https://m.site.naver.com/2aXOw>



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COMPOUND SEMICONDUCTOR TECHNOLOGY ASSOCIATION



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